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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF 2800  
PATENT  
09/864,714

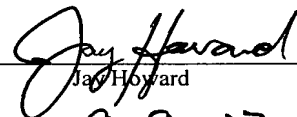
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TECHNICAL CENTER 2800

In re Application of: Ajit P. Paranjpe et al.  
Serial No.: 09/864,714  
Filing Date: May 23, 2001  
Group Art Unit: 2814  
Examiner: Rao, Shrinivas H.  
Title: *Atomic Layer Deposition For Fabricating Thin Films*

MAIL STOP AF

Commissioner for Patents  
Alexandria, VA 22313

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail No. **EV341125825US** in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313, on the date shown below.

  
Jay Howard

9-9-03  
Date of Signature

**RESPONSE TO FINAL OFFICE ACTION**

Dear Sir:

In response to the Final Office Action mailed July 14, 2003 (Paper No. 10), Applicants respectfully request that the Examiner reconsider application in view of the following amendments and remarks:

**Amendments to Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** being on page 6 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

**Remarks/Arguments** begin on page 7 of this paper.